



Filed Via Express Mail pursuant to 37 C.F.R. 1.10

Record No. 54796871545

On: Aug-9-06

By: Peterson

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Toru TATSUMI et al.

Serial No.: 09/744,701

Confirmation No.: 3273

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC FILM AND APPARATUS FOR
VAPOR PHASE GROWTH OF METAL DIELECTRIC
MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Attorney Docket No.: NECW 18.281 (100806-17349)

August 9, 2006

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the final Office Action dated February 14, 2006, please amend the subject application as follows: